



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Warren M. Farnworth

Serial No.: 10/663,944

Filed: September 16, 2003

For: STEREO LITHOGRAPHIC METHOD
FOR FORMING INSULATIVE COATINGS
FOR VIA HOLES IN SEMICONDUCTOR
DEVICES (Amended)

Confirmation No.: 3861

Examiner: W. Brewster

Group Art Unit: 2823

Attorney Docket No.: 2269-5700US
(02-1183.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

February 15, 2005
Date

Rachael Harris
Signature

Rachael Harris
Name (Type/Print)

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is being filed in response to the Final Office Action mailed on December 15, 2004, the three-month shortened statutory period for response to which expires on March 15, 2005. This Amendment is being submitted within two months of the mailing date of the Final Office Action.

An amendment to the title appears on page 2 of this paper;

Amendments to the claims are set forth in the listing of the claims, which begins on page 3 of this paper; and

Remarks start at page 7 of this paper.

Do Not Enter

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